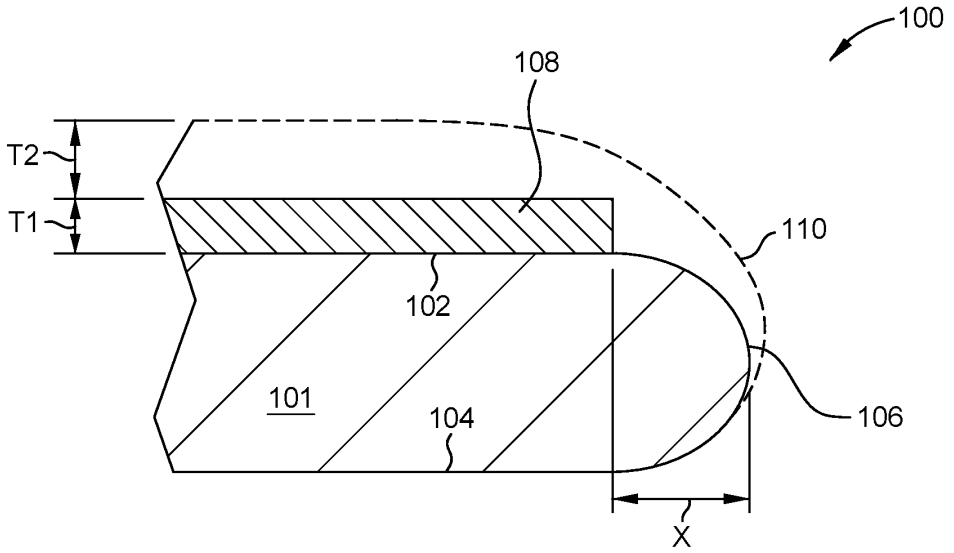


FIG. 1A

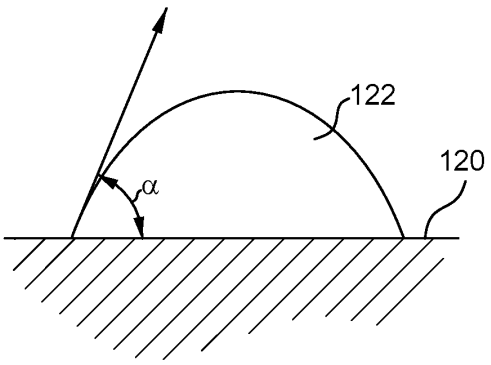


FIG. 1B

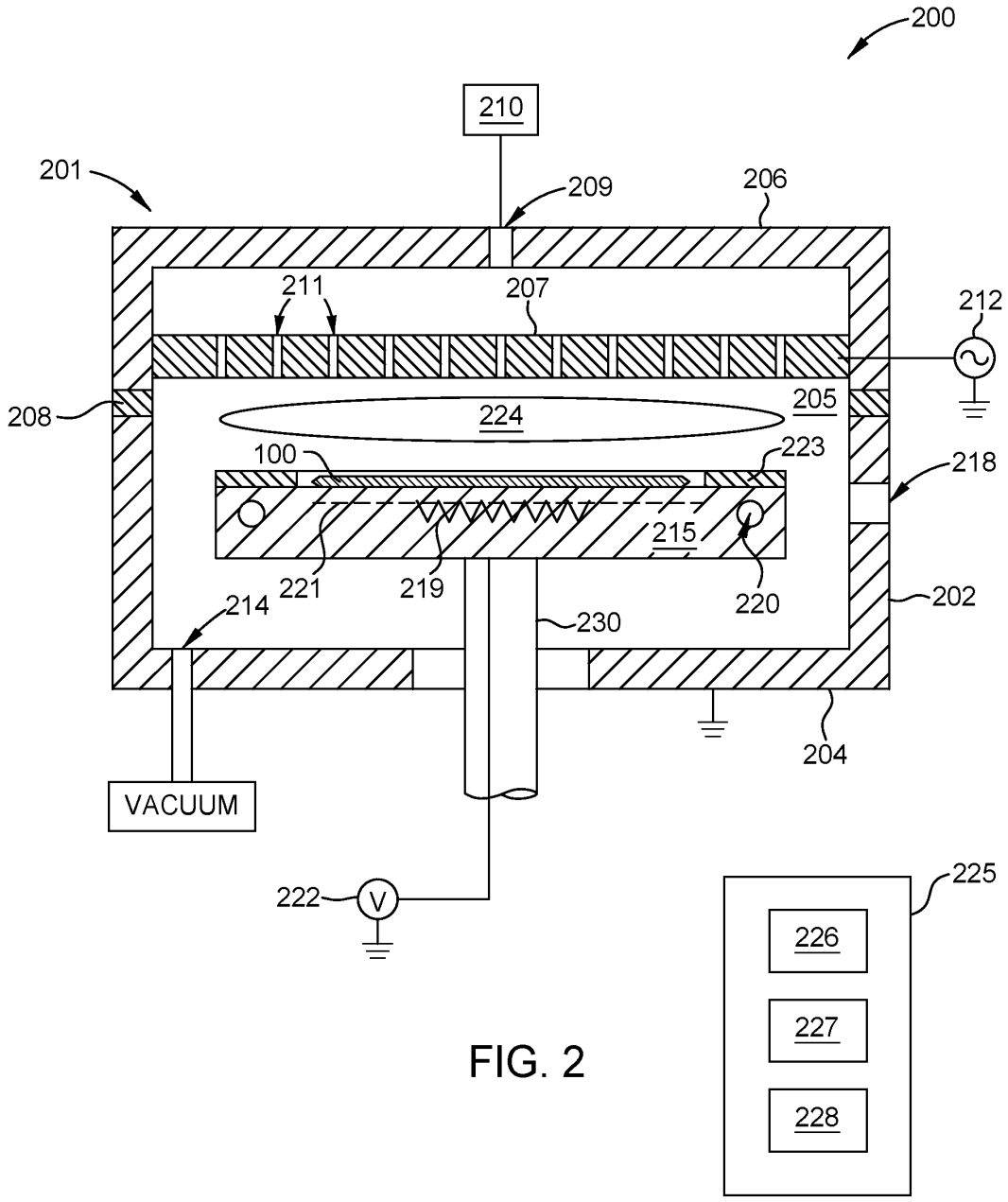

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FIG. 2

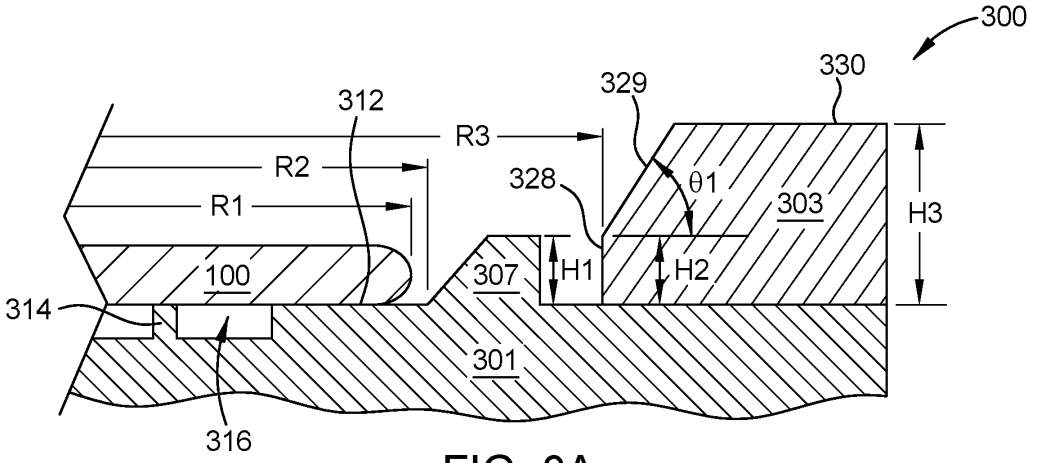


FIG. 3A

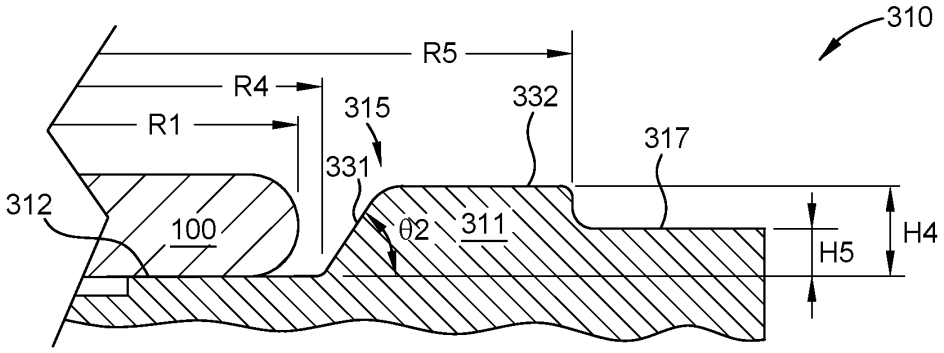


FIG. 3B

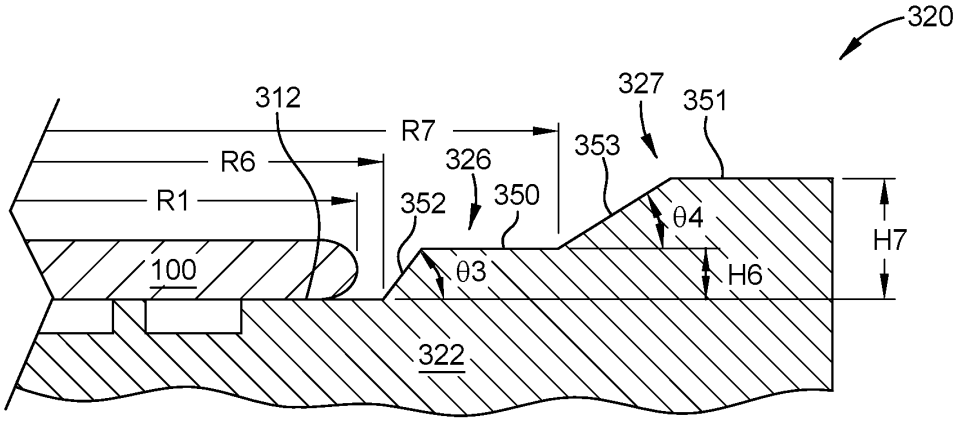


FIG. 3C

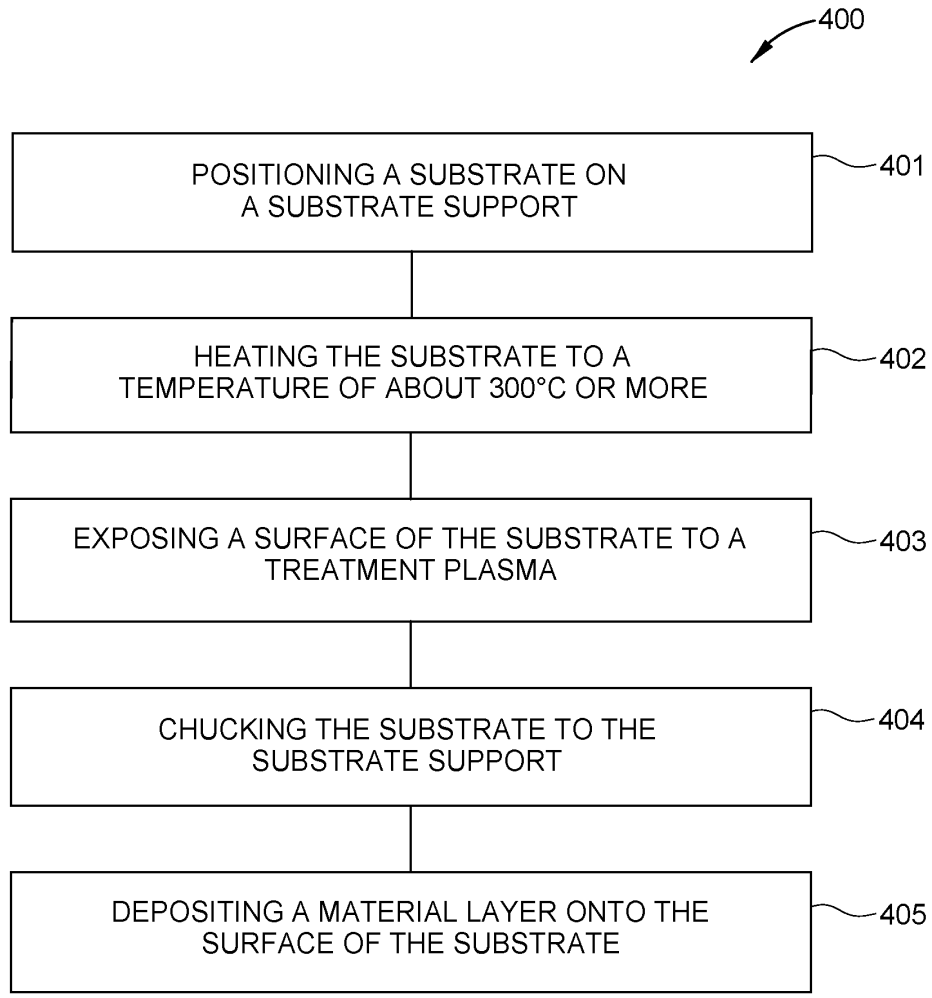

400
POSITIONING A SUBSTRATE ON A SUBSTRATE SUPPORT
401
HEATING THE SUBSTRATE TO A TEMPERATURE OF ABOUT 300°C OR MORE
402
EXPOSING A SURFACE OF THE SUBSTRATE TO A TREATMENT PLASMA
403
CHUCKING THE SUBSTRATE TO THE SUBSTRATE SUPPORT
404
DEPOSITING A MATERIAL LAYER ONTO THE SURFACE OF THE SUBSTRATE
405

FIG. 4